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(54) Title: TARGET ASSEMBLY SYSTEM AND METHOD

(57) Abstract: A system includes a nozzle configured to eject a liquid. The system also includes a wall having a surface facing the nozzle, and a thickness extending from the surface. The system also includes one or more capacitance sensors configured to detect, through the thickness of the wall, a presence of the liquid at or adjacent to the surface.

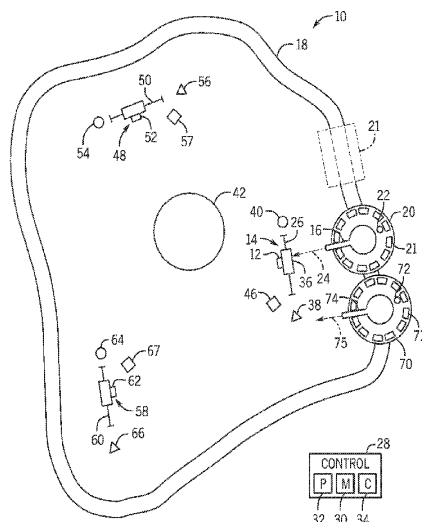


FIG. 1

Declarations under Rule 4.17:

- *as to applicant's entitlement to apply for and be granted a patent (Rule 4.17(ii))*
- *as to the applicant's entitlement to claim the priority of the earlier application (Rule 4.17(iii))*

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